Application/Control No.	Applicant(s)/Patent under Reexamination
10/786,493	HAYASHI, ISAO
Examiner	Art Unit
Pia F. Tibbits	2838

	SEARCHED				
Class	Subclass	Date	Examiner		
363	23	9/5/2006	PT		
	26				
320	118				
	128				
	135				
	136				
	132				
	152				

INT	INTERFERENCE SEARCHED					
Class	Subclass	Date	Examiner			
	<u> </u>					

DATE	EXMR
	1